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SERIAL NUMBER 10/773,293	FILING DATE 02/09/2004 RULE	CLASS 355	GROUP ART UNIT 2851	ATTORNEY DOCKET NO. 247903US90CONT
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APPLICANTS

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** CONTINUING DATA *****

This application is a CON of 09/618,550 07/17/2000 ABN
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HN

** FOREIGN APPLICATIONS *****

JAPAN 10-020479 01/16/1998

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** 05/06/2004

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY	SHEETS DRAWING	TOTAL CLAIMS	INDEPENDENT CLAIMS
Verified and Acknowledged	Examiner's Signature HN	JAPAN	9	51	11

ADDRESS

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TITLE

Exposure method and lithography system, exposure apparatus and method of making the apparatus, and method of manufacturing device

FILING FEE RECEIVED 2016	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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